

Serial No. 10/016,562

OFFICIAL

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Chang-Lin Hsieh.

Serial No.: 10/016,562

Filed: 12/12/2001

Title: Process for Selectively Etching Dielectric Layers

Art Unit: 1765

Examiner: Deo, Duy Vu Nguyen

Docket No.: 004544/ALRT/ETCH/DICP

VIA FACSIMILE 703-872-9311

Mail Stop Box AF

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

RESPONSE TO OFFICE ACTION

Sir:

This is responsive to the final Office Action mailed March 4, 2004 in the above matter.

1765

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To: Commissioner for Patents

From: David Bonham
(703) 433-0510

Fax: 703-872-9311

Total pages: 17

Phone:

Date: 6/4/2004

Re: In connection with the prosecution in Serial No:
10/016,562, please find enclosed a response to
the Office Action mailed March 4, 2004.

CC:

Sincerely,

David Bonham

Urgent **For Review** **Please Comment** **Please Reply** **Please Recycle**

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